

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 0068-0399-0		SERIAL NO. 09/420,524 New Application	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Masakazu KANECHIKA, et al.			
		FILING DATE		Herewith		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
JAG	AO	6-163481	06/10/94	JAPAN (with English Abstract)	YES		XX
JAG	AP	9-260312	10/03/97	JAPAN (with English Abstract)	YES		XX
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
JAG	AW	Seigo KANEMARU, et al., "FABRICATION OF METAL-OXIDE-SEMICONDUCTOR FIELD-EFFECT-TRANSISTOR-STRUCTURED SILICON FIELD EMITTERS WITH A POLYSILICON DUAL GATE", Jpn. J. Appl. Phys., Vol. 36, Part 1, No. 12B, December 1997, pages 7736-7740					
JAG	AX	Yoshikazu HORI, et al., "NEW SUB-MICRON SIZE Si FIELD Emitter ARRAYS WITH LOW OPERATION VOLTAGE", Technical Report of The Institute of Electronics Information and Communication Engineers, ED94-95, 1994-12, pages 1-8, (With English Abstract)					
	AY						
	AZ						
Examiner	<i>Jeannie A. Garcia</i>				Date Considered <i>July 13, 2002</i>		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							